

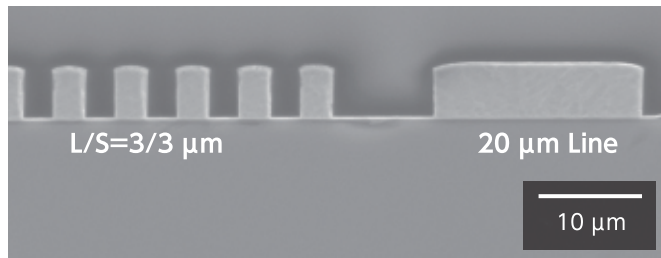
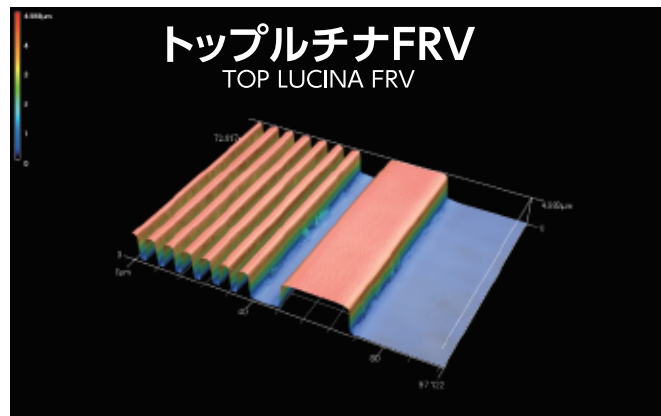
トッパールチナFRV

TOP LUCINA FRV

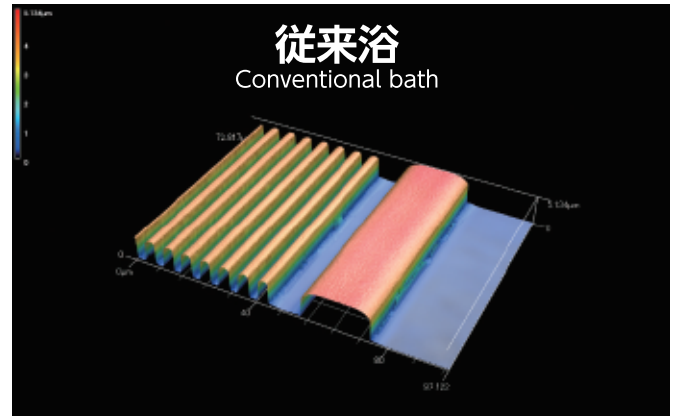
- パターン幅にかかわらず、良好な矩形配線を実現
Regardless of pattern size/density, square-shape patterns can be obtained
- 高い膜厚均一性 (L/S = 2/2 μm対応)
Uniform thickness is available (Applicable to line / space = 2/2 μm)
- 微小ビア(ビア径10 μm)のフィリングに対応
Micro-via filling is possible (Hole diameter: 10 μm)

良好な矩形配線

Square-shape patterns can be obtained



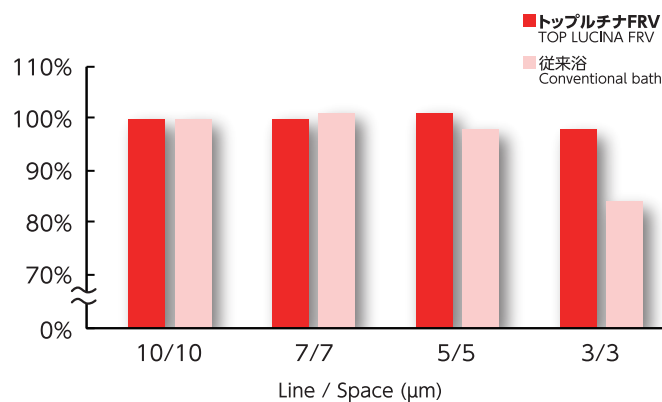
矩形性 **4.9%**
Square-shape ratio



矩形性 **20.2%**
Square-shape ratio

高い膜厚均一性

Excellent in thickness uniformity



Line / Spaceと膜厚の関係
Relationship of line /space and film thickness
(L/S=10/10 μmのときの膜厚を100%とする)
Set the film thickness at L/S=10/10 μm as 100%

微小ビアのフィリングに対応

Micro-via filling is possible

微小ビア(φ10 μm) 断面観察像
Cross section image of micro-via (Hole diameter: 10 μm)

